	Application No.	Applicant(s)	
Aladiaa of Allawahilide	10/623,748	TANAKA, YASUO	
Notice of Allowability	Examiner	Art Unit	
	Ngan Ngo	2814	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.			
1. This communication is responsive to .			
2. The allowed claim(s) is/are <u>1-27</u> .			
3. The drawings filed on 22 July 2003 are accepted by the Ex	kaminer.		
 4.			
Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 0703 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. ☐ Notice of Informal F 6. ☐ Interview Summary Paper No./Mail Da 7. ☐ Examiner's Amendr	Patent Application (PTO-152) (PTO-413), te	

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Reasons for Allowance

The following is an examiner's statement of reasons for allowance:

The prior arts of record do not show the semiconductor device having bump electrodes electrically connected to connection pads formed on a semiconductor chip and the sealing region film comprising a low-elastic resin formed on the surface of the semiconductor chip and a high-elastic resin layer formed on the surface of the low-elastic resin layer and having an elastic coefficient higher than that of the low-elastic resin layer in which the thickness of the high-elastic resin layer is between 5 µm and 45µm.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication should be directed to Examiner Ngan Ngo at telephone number (571) 272-1711. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

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you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Mgan Van Ngo >াmany Examinor

Ngan Ngo November 5, 2004